

Notice of References Cited

Application/Control No.

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Applicant(s)/Patent Under
Reexamination
NIEMI, AKI

Examiner

PIERRE-LOUIS DESIR

Art Unit

2617

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0037406	02-2004	Gourraud, Christophe	379/202.01
*	B	US-2002/0078153 A1	06-2002	Chung et al.	709/204
	C	US-			
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	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

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